



# Modeling Phonon-mediated Quasiparticle Poisoning and Particle Impacts using G4CMP

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#### **Controlled Phonon-mediated Poisoning** $\rightarrow T_{\text{pulse}}$ $525 \, \mu m$ 8 0.3 2 $x_{qp} \ (10^{-6})$ $\Delta \Gamma_1 \; (\mu { m s}^{-1})$ 6 8 mm Non-Cu 0.2 8 mm (#|5) 0.1 0.0 Nb Ground plane device 25 50 75 100 125 150 200 0 175 Delay $(\mu s)$ Array of six charge- $10 \ \mu s$ sensitive Transmons Delayı $J_{inj}$ $\pi$ $\Delta\Gamma_1$ $x_{qp}$ $Q_i$ $\Delta\Gamma_1$ $\overline{T^b_{\scriptscriptstyle 1}}$ $\overline{T_1}$ $\omega_{01}2$

laia, Ku et al., Nature Comm. 13, 6425 (2022)

# **Controlled Phonon-mediated Poisoning**



laia, Ku et al., Nature Comm. 13, 6425 (2022)

# Numerical Model of Phonon Injection

Geant4 Condensed Matter Physics (**G4CMP**)– Monte Carlo simulation toolkit to simulate particle transport in various materials

- Simulates production and transport of  $e^-/h^+$  pairs and phonons in crystals
- Simulates quasiparticle (QP) production in superconducting films



# Numerical Model of Phonon Injection



## Numerical Model of Phonon Injection



#### Model of Qubit Electrodes



# Model of Qubit Electrodes

#### **Custom PhononElectrode class**

**Materials** handled via custom child class of G4CMPSurfaceProperty



# Model of Qubit Electrodes and Backside Films

#### **Custom PhononElectrode class**

**Materials** handled via custom child class of G4CMPSurfaceProperty



Similar scheme for backside metallization

$$egin{aligned} rac{\mathrm{d}x_{qp}}{\mathrm{d}t} = -rx_{qp}^2 - sx_{qp} + g(t) \end{aligned}$$





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#### **From G4CMP Simulation**



G4CMPElectrodeHit-> GetEnergyDeposit() from phonon energy deposition result from G4CMPKaplanQP



### Injection Modeling Results



laia, Ku et al., Nature Comm. 13, 6425 (2022)

#### Injection Modeling Results



# Modeling a Dense Qubit Array

- The Al patches that model the qubit electrodes are arranged in a on the ground plane
- We make use of the G4CMP toolkit to model the phonon burst from a typical gamma impact
  - Typical background  $\gamma$  creates ~30,000  $e^-/h^+$  pairs







Phonon burst from a single  $e^-/h^+$  pair of energy 3.6 eV

# Modeling a Dense Qubit Array

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Custom PhononElectrode





## QP poisoning from a gamma-ray impact



Yelton et al., arXiv:2402.15471 (2024)

### QP poisoning from a gamma-ray impact



Yelton et al., arXiv:2402.15471 (2024)



# Conclusion

- Shown a realistic model of QP poisoning in superconducting qubit devices
- Modeled dense qubit arrays while exposed to a background gamma-ray impact
   arXiv:2402.15471



# Back-up Slides

#### Injection on an Al GND plane device



We only saw agreement between modeling and data when scaling generation term in post

Al

Si

#### **QP** Diffusion

$$D(E_{qp}) = D_n \sqrt{1 - \left(rac{\Delta}{E_{qp}}
ight)^2}$$

$$\Gamma^s_{qp}(E_{qp})pprox rac{1.8}{ au_0^{qp}}igg[igg(rac{E_{qp}}{\Delta}igg)-1igg]^3$$



$$D_n = 6 \ \mu {
m m}^2 {
m ns}^{-1} \ au_0^{qp} = 440 \ {
m ns}$$

$$D_n = 0.88 \ \mu {
m m}^2 {
m ns}^{-1} \ au_0^{qp} = 0.15 \ {
m ns}$$

# Formulating the generation term

g(t) is the convolution of a response function to an injection rate pulse

$$g(t) = \int^t h(t- au) I_{ph}( au) \mathrm{d} au$$

In the simulation the routine all phonons are injected at t=0. Thus,

$$I_{ph}(t) = N^s_{ph} \delta(t) o h(t) = rac{N_{qp}(t)}{V \Delta t N^s_{ph}}$$

Discretizing the first equation with the above response function gives the following:





# Phonon injection rate $I_{ph}(t)$

In solving the QP density equation the time dependent phonon injection rate should match our experimental parameters



Parity Switching data



laia, Ku et al., Nature Comm. 13, 6425 (2022)

Yelton *et al.*, preprint arXiv:2402.15471 (2024)



# Phonon Absorption

In general, the absorption probability of elastic plane wave at the interface of two semi-infinite media depends on material properties, the angle of incidence and the polarization of the waves



 $\eta_T \& \eta_L$  are angle averaged transmission coefficients

We take the probability for a phonon in the Si substrate to be absorbed into a superconducting film to be the sum of the angle averaged transmissions coefficients for each mode weighted by the density of states in Si.

$$p_{abs}=0.907\eta_T+0.093\eta_L$$



Due to anisotropies in the elasticity tensor the group velocity is generally not in the same direction as the wavevector



#### QP density Wall Abs. and Trapping rate



Inverse trapping rate of 20 us

$${
m Gap\ of\ the\ electrodes}\ \Delta(d) = \Delta_{
m bulk} + rac{600\ \mu {
m eVnm}}{d}$$

 $\Delta(40 \text{ nm}) = 195 \ \mu \text{eV} \qquad \Delta(80 \text{ nm}) = 187.5 \ \mu \text{eV}$ 

- We have 40 nm / 80 nm dolan bridge style junctions
- Assume the simulated junction patches have a gap of the average of the two films ~ 191 ueV and a total thickness of 120 nm



# Other film parameters

- Gap Energy Table IV from <u>this source</u>
- Phonon Lifetime slope  $\delta au^{ph}$  is 0.29
- vSound long. and trans. modes are weighed by the DOS of phonons in Si. The sound speeds are from <u>this</u> <u>source.</u>

$$egin{aligned} 
u_{ ext{sound}} &= ext{DOS}_{ ext{Si}}^{ ext{trans.}} 
u_{ ext{trans.}} + ext{DOS}_{ ext{Si}}^{ ext{long.}} 
u_{ ext{long.}} \ 
u_{ ext{sound}} &= ext{0.907} 
u_{ ext{trans.}} + ext{0.093} 
u_{ ext{long.}} \end{aligned}$$



# Motivation

- Background γ-rays and cosmic ray muons create a burst of charge and phonons in Si
- Energetic phonons break cooper pairs creating QPs which cause correlated errors





McEwen et al., *Nature Physics* 18, 107 (2021)



Wilen et al., *Nature* 594, 7863 (2021)

### Charge Transport

E.O.M.: 
$$\frac{eE_i}{m_i} = \frac{dv_i}{dt} \rightarrow \frac{eE_i^*}{m_{\text{eff}}} = \frac{dv_i^*}{dt} \text{ where } v_i^* = \frac{v_i}{\sqrt{m_{\text{eff}}/m_i}}$$
Electron mass tensor  
- Mass of holes is scalar  

$$T_{\text{HV}} = \begin{pmatrix} \sqrt{\frac{m_{\text{eff}}}{m_x}} & 0 & 0 \\ 0 & \sqrt{\frac{m_{\text{eff}}}{m_y}} & 0 \\ 0 & 0 & \sqrt{\frac{m_{\text{eff}}}{m_z}} \end{pmatrix}$$

$$W \text{ Ashareft N.D. Marmin Solid State}$$

 $egin{aligned} ext{Charge Trapping} & ext{Impact}\ e^-D^0 & D^- & e^-D^- \ h^+D^- & \to D^0 & h^+D^- \ e^-A^+ & \to A^0 & e^-A^+ \ h^+A^0 & \to A^+ & h^+A^+ \end{aligned}$ 

Impact Ionization

- $e^-D^- 
  ightarrow e^-e^-D^0$
- $h^+D^- o h^+e^-D^0$
- $e^-A^+ o e^-h^+A^0$

 $h^+A^+ o h^+h^+A^0$ 

N. W. Ashcroft, N. D. Mermin, Solid State Physics, College Edition, Saunders College Publishing, 1976

- Intervalley Scattering : Electrons are scattered from absorption of thermal phonons-> momentum transfer from one valley to another
- Charges recombine and emit half of band gap energy as phonons at Debye freq (62.03 meV)



N. W. Ashcroft, N. D. Mermin, Solid State Physics, College Edition, Saunders College Publishing, 1976

- Wave equation is not solved in real-time but by using a look-up table
- Only Acoustic phonons are modeled
- Optical phonons immediately decay into acoustic modes in mK limit -> drawback photon-phonon scattering is not modeled

#### Superconducting Film Boundaries

$$\begin{aligned} & \text{QP downconversion } q \to q + p \\ & \Gamma_q^s(\epsilon) = \frac{1}{\tau_0} \int_{\Delta}^{\epsilon} d\epsilon' \frac{(\epsilon - \epsilon')^2}{(kT_C)^3} \rho(\epsilon') \left(1 - \frac{\Delta^2}{\epsilon\epsilon'}\right) \\ & P_{ph}(E_q) = \frac{(E_q - E_q')^2}{(kT_C)^3} \rho(E_q') \left(1 - \frac{\Delta^2}{E_q E_q'}\right) \\ & \text{Pair breaking } p \to q + q \\ & \Gamma_p^b(E_p) = \frac{1}{\pi \tau_0^{ph} \Delta} \int_{E_p - \Delta}^{\Delta} d\epsilon \rho(\epsilon) \rho(E_p - \epsilon) \left(1 + \frac{\Delta^2}{\epsilon(E_p - \epsilon)}\right) \\ & P_{QP}(E_q) = \rho(E_q) \rho(E_{\text{phonon}} - E_q) \left(1 + \frac{\Delta^2}{E_q(E_{\text{phonon}} - E_q)}\right) \end{aligned}$$

$$P_{ ext{escape}} = \expigg(rac{-2*2d}{\lambda(E_{ ext{phonon}})}igg) \qquad \lambda(E_{ph}) = rac{v_{ ext{sound}}\, au}{1+\delta au\cdot(E_{ph}/\Delta-2)}$$

#### Normal Metal Film Boundaries

QP downconversion / Electron Relaxation

$$P_{ph}(E_q) = rac{(E_q - E_q')^2}{(kT_C)^3} 
ho(E_q') \left(1 - rac{\Delta^2}{E_q E_q'}
ight) 
ho 
ho$$
Pair breaking / Electron excitation
 $P_{QP}(E_q) = 
ho(E_q) 
ho(E_{ ext{phonon}} - E_q) \left(1 + rac{\Delta^2}{E_q(E_{ ext{phonon}} - E_q)}
ight)$ 

$$P_{ph}(E_q) \propto (E_q - E_q')^2$$

$$P_{QP}(E_q) = 1$$

$$P_{ ext{escape}} = \expigg(rac{-2*2d}{\lambda(E_{ ext{phonon}})}igg) \qquad \lambda = rac{v_L}{\Gamma} \quad \Gamma_{ ext{p}
ightarrow ext{e}+ ext{e}} = rac{1}{8.2 ext{ns}}igg(rac{T_{ ext{p}}}{ ext{K}}igg)$$